



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 31, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG695515693

LABORATORY GROWN DIAMOND

OCTAGONAL STEP CUT

6.21 X 6.20 X 3.68 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.04 CARAT

F

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG695515693

PROPORTIONS

Medium

59%

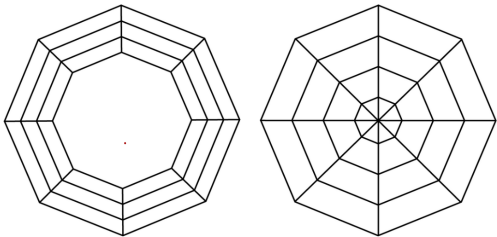
15%

42%

59.4%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

LABORATORY GROWN DIAMOND REPORT



March 31, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG695515693

LABORATORY GROWN DIAMOND

OCTAGONAL STEP CUT

6.21 X 6.20 X 3.68 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.04 CARAT

F

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS

Medium

59%

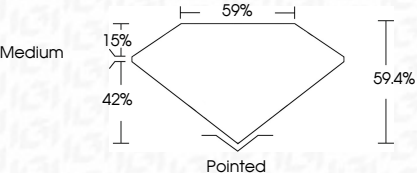
15%

42%

59.4%

Pointed

CLARITY CHARACTERISTICS



IGI



IGI



IGI



© IGI 2020, International Gemological Institute

FD - 10 20

IGI



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

March 31, 2025

IGI Report No LG695515693

OCTAGONAL STEP CUT

6.21 X 6.20 X 3.68 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.04 CARAT

F

VVS 2

59.4%

59%

Medium

Pointed

EXCELLENT

EXCELLENT

NONE

 LG695515693

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa